

RCE

**REQUEST  
FOR  
CONTINUED EXAMINATION (RCE)  
TRANSMITTAL**

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450



Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000,  
provides for continued examination of an utility or  
plant application filed on or after June 8, 1995

Application Number	10/084,204
Confirmation Number	6177
Filing Date	February 28, 2002
First Named Inventor	Takako SUZUKI
Group Art Unit	1752
Examiner Name	John S. Y. Chu
Matter Number	Q67844

Title

**POSITIVE PHOTORESIST COMPOSITION  
AND PROCESS FOR FORMING RESIST  
PATTERN USING SAME**

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

**1. SUBMISSION REQUIRED UNDER 37 C.F.R. § 1.114**

- a. ☐ Previously submitted
- i. ☐ Please enter and consider the amendment(s)/reply under 37 C.F.R. § 1.116  
previously filed on \_\_\_\_\_
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on \_\_\_\_\_
- iii. ☐ Other \_\_\_\_\_
- b. ☒ Enclosed
- i. ☒ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☒ Information Disclosure Statements (IDS)
- iv. ☒ Petition for Extension of Time
- v. ☐ Other \_\_\_\_\_

**2. MISCELLANEOUS**

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a  
period of \_\_\_\_\_ Months
- b. ☐ Other \_\_\_\_\_

**3. FEES**

Checks for the RCE statutory fee of \$770.00 and for the Petition for Extension of Time statutory fee (for one  
(1) month) of \$110.00 are attached. The USPTO is directed and authorized to charge all required fees, except for the  
Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said  
Deposit Account. A duplicate copy of this transmittal letter is attached.

**CORRESPONDENCE ADDRESS**

*Direct all correspondence to the address for SUGHRUE MION, PLLC filed under the Customer Number listed below:*

09/21/2004 HVUONG1 00000059 10084204

01 FC:1801

770.00 0P

WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

**SIGNATURE OF ATTORNEY**

Name Patrick F. Gallagher Registration No. 54,109

Signature  Date September 20, 2004



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q67844

Takako SUZUKI, et al.

Appln. No.: 10/084,204

Confirmation No.: 6177

Group Art Unit: 1752

Filed: February 28, 2002

Examiner: John S. Y. Chu

For: POSITIVE PHOTORESIST COMPOSITION AND PROCESS FOR FORMING RESIST  
PATTERN USING SAME

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

A RCE and Petition for Extension of Time (for one (1) month) is filed concurrently herewith, thus extending the time for responding to the Final Office Action of May 18, 2004, from August 18, 2004, to September 20, 2004 (September 18, 2004 being a Saturday). Please amend the above-identified application as follows:

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS .....	2
REMARKS .....	5